



## Science and Technology of Materials, Interfaces, and Processing

### Topical Areas

Biomaterials  
Environmental S&T  
Magnetic Materials  
Manufacturing S&T  
Materials Characterization  
Materials Processing  
MEMS  
Microelectronic Materials  
Nanometer-Scale S&T  
Plasma S&T  
Surface Engineering  
Surface Science  
Thin Films  
Vacuum Technology

### Contacts

Administrative Director  
212-248-0200, ext. 222

Exhibition  
212-248-0200, ext. 229

Finance  
212-248-0200, ext. 224

Marketing/Meetings  
530-896-0477

Member Services  
212-248-0200, 221

Short Courses  
530-896-0477

Web/IT  
212-248-0200, ext. 223

## Press Invitation

We hope that you will join us at the AVS 54<sup>th</sup> International Symposium and Exhibition being held October 14-19, 2007, at the Washington State Convention Center in Seattle, Washington.

More than 1,200 papers in all areas of vacuum-related technology, including biomaterials interfaces, thin films, processing, electronics, and nanotechnology, will be presented at this weeklong technical symposium. In addition, the symposium will feature 150-plus exhibitors showing the most advanced equipment and services available in these fields.

The exhibit hours are:

- Tuesday, 10:00 a.m.-6:00 p.m.
- Wednesday, 10:00 a.m.-5:00 p.m.
- Thursday, 10:30 a.m.-3:00 p.m.

The AVS Pressroom will be located in Room 601 of the Washington State Convention Center. Pressroom hours are: Monday-Thursday, 8:00-5:00 p.m.

Your press badge will allow you to utilize the pressroom to write, interview, collect new product releases, review material, or just relax. The press badge will also admit you, *free of charge*, into the exhibit area, lectures, and technical sessions, etc. It will also admit you into the Welcome Mixer on Monday Evening as well as the Awards Ceremony and Reception on Wednesday night.

The Technical Program containing all symposium and exhibition details, including travel information may be found on the AVS Website at [www.avs.org](http://www.avs.org).

To register (complimentary) as a member of the press, please complete the attached form and fax by October 2, 2007 to: Della Miller, AVS, fax 530-896-0487. You may also complete the form online at:

While pre-registration is not mandatory, this will enable us to prepare your registration packet and press badge in advance.

You may pick up your press badge in the main registration area on:

- Sunday, 2:00 p.m.-6:00 p.m.
- Monday, 7:00 a.m.-5:00 p.m.
- Tuesday, 7:00 a.m.-6:00 p.m.
- Wednesday-Thursday, 7:30 a.m.-5:00 p.m.

Press Kits containing exhibiting company's new product announcements and other news will be available on CD-ROM in the pressroom.

AVS  
110 Yellowstone Dr., Ste. 120  
Chico CA 95973

Phone: 530-896-0477  
Fax: 530-896-0487  
E-mail: [della@avs.org](mailto:della@avs.org)  
Web: [www.avs.org](http://www.avs.org)

## AVS Press Registration Form

AVS 54<sup>th</sup> International Symposium and Exhibition

October 14-19, 2007

Washington State Convention Center

Preregister by October 2, 2007

Name: \_\_\_\_\_

Title: \_\_\_\_\_

Name of Publication(s): \_\_\_\_\_

Address: \_\_\_\_\_

\_\_\_\_\_

Phone: \_\_\_\_\_ Fax: \_\_\_\_\_

E-mail: \_\_\_\_\_

### Press Kit Preferences

- I prefer to pick up my press kit in the pressroom at the conference (CD-ROM)
- I prefer to receive my press kit after the conference (CD-ROM)

### Attendance Plans

- Yes, I plan to attend the Monday Plenary Lecture
- Yes, I plan to attend the Monday Welcome Mixer
- Yes, I plan to attend some of the Exhibitor Workshops throughout the week
- Yes, I will be available to schedule appointments with exhibitors upon request